

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  INFORMATION DISCLOSURE STATEMENT BY APPLICANT  (USE SEVERAL SHEETS IF NECESSARY)	ATTY. DOCKET NO. NEDER29.001DV1	APPLICATION NO. Unknown
	APPLICANT Arjen Storm et al.	
	FILING DATE Herewith	GROUP Unknown 1742

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
SK	1	4,495,024	01/22/85	Bok			
	2	4,560,590	12/24/85	Bok			
	3	4,575,408	03/11/86	Bok			
	4	4,860,687	08/29/89	Frijlink			
	5	4,975,561	12/04/90	Robinson et al.			
	6	5,314,848	05/24/94	Yasui et al.			
	7	5,332,442	07/26/94	Kubodera et al.			
	8	5,414,244	05/1995	Imahashi			
	9	5,430,271	07/04/95	Orgami et al.			
	10	5,650,082	07/22/97	Anderson			
	11	5,790,750	08/04/98	Anderson			
	12	6,018,616	01/25/00	Schaper			
	13	6,064,799	05/16/00	Anderson et al.			
	14	6,072,163	06/2000	Armstrong et al.			
	15	6,080,969	06/27/00	Goto et al.			
	16	6,097,005	08/01/00	Akimoto			
	17	6,111,225	08/29/00	Ohkase et al.			
	18	6,183,565	02/06/01	Granneman et al.			
	19	6,207,936	03/27/01	De Waard et al.			
	20	6,234,788	05/2001	Lee			
	21	6,275,744	08/2001	Yshida			
	22	6,329,304	12/11/01	Kuznetsov et al.			
SK	23	2003-0209327 A1	05/08/02	Kuznetsov et al.			

EXAMINER S. Kastler	DATE CONSIDERED 3-05
*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.	

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FOREIGN PATENT DOCUMENTS								
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
SK	24	08236533	09/13/96	EP				
	25	10321505	12/04/98	EP				
	26	00/42638	07/20/00	WO				
	27	00/68977	11/16/00	WO				
	28	JP 402034915 A	02/05/90	Japan				
	29	JP 404078310 A	03/12/92	Japan				
	30	JP 361294812 A	12/25/86	Japan				
SK	31	JP 362021237 A	01/29/87	Japan				

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)	
SK	32	Porter et al., "Fast-ramp rapid vertical processor for 300-mm Si wafer processing". SPIE vol 3507, <u>September 1998</u> , p 42-53.

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EXAMINER <u>S. Kastler</u>	DATE CONSIDERED <u>3-05</u>
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